

Supporting information

Fabrication of Temperature Sensors with High-Performance Uniformity through Thermal Annealing

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1. The I-V curves of the Gr-AC temperature sensor at room temperature

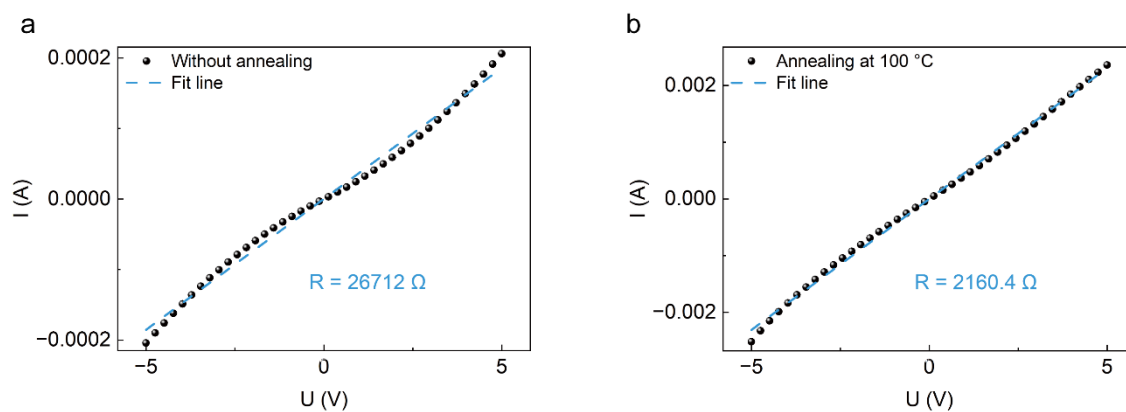


Figure S1. The I-V curves of the Gr-AC temperature sensor at room temperature. After annealing, the DC resistance is significantly reduced.

2. The annealing time

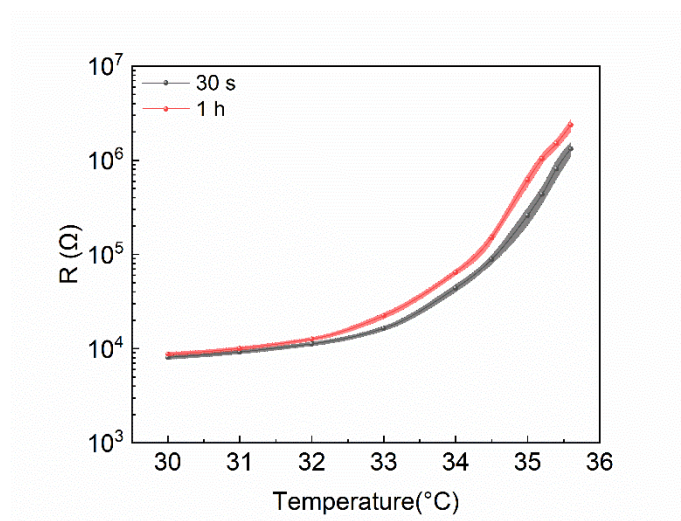


Figure S2. Performance comparison of 10 temperature sensors annealed at 100 $^{\circ}\text{C}$ for 30 s and 1 h. The error bar represents the standard error.

3. Calculation of grayscale values for SEM images

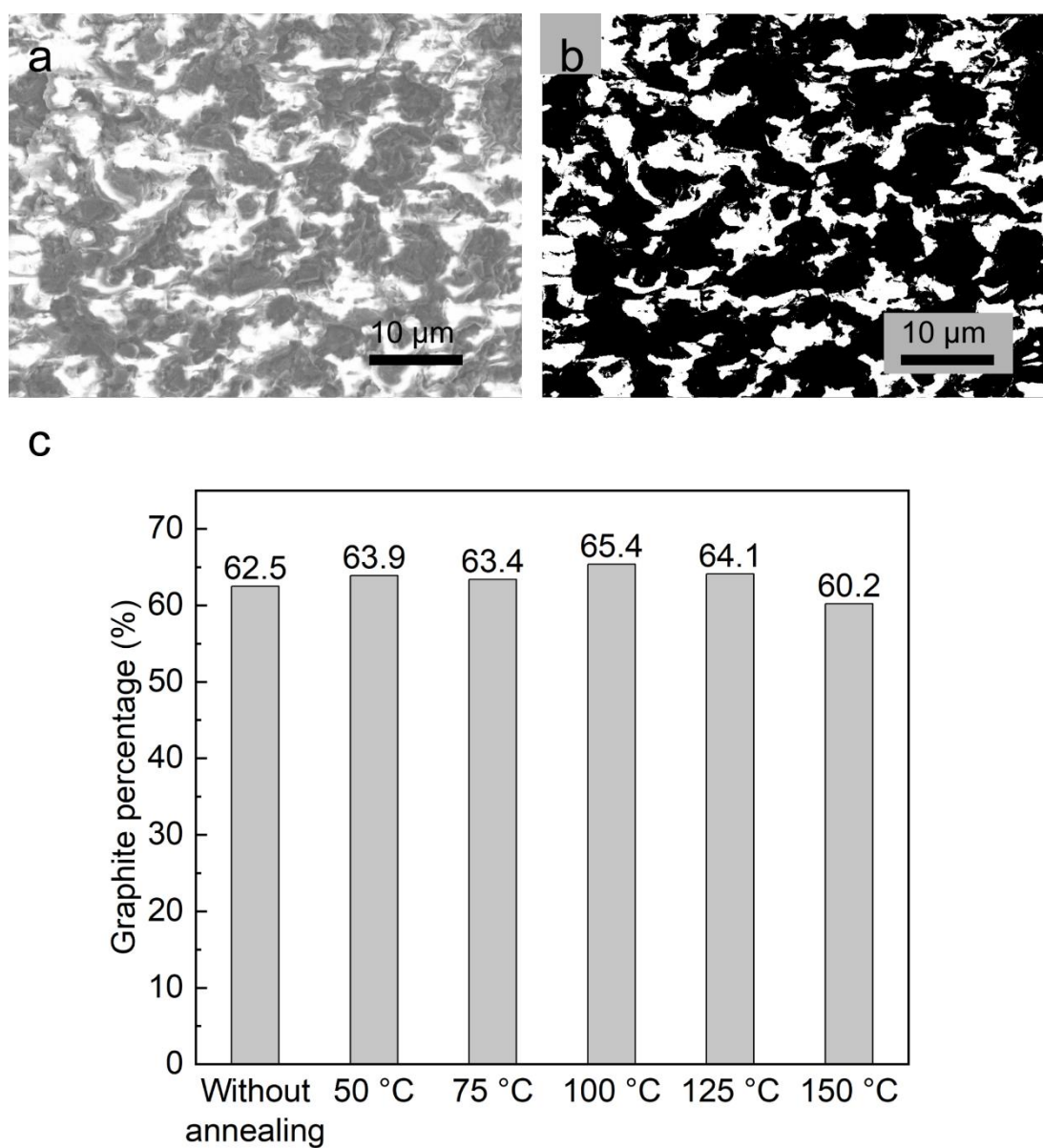


Figure S3. a) The original and SEM image. b) Image after binarization. The grayscale threshold is set to 0.65. c) Graphite percentage of Gr-AC composite under unannealed and annealing at 50, 75, 100, 125, and 150 $^{\circ}\text{C}$, respectively.